



Attorney Docket # 5300-17

Patent

365 2A/11/2002 #6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Neil S CASA

Serial No.: 10/007,618

Filed: November 07, 2001

For: System And Method For Inhibiting Motion Of  
Semiconductor Wafers In A Variable-Pressure  
Chamber

Examiner:

Group Art:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

November 8, 2002

(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

*Thomas Langer*  
Signature

November 8, 2002

Date of Signature

Box PG Pub  
Assistant Commissioner for Patents  
Washington, DC 20231

**REQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST  
UNDER 35 U.S.C. 122(b)(2)(B)(ii)**

SIR:

I hereby rescind the previous request that the above-identified application not be published under 35 U.S.C. 122(b).

Respectfully submitted,  
COHEN, PONTANI, LIEBERMAN & PAVANE

By

*Thomas Langer*

Thomas Langer  
Reg. No. 27,264  
551 Fifth Avenue  
New York, New York 10176  
(212) 687-2770

Dated: November 8, 2002

RECEIVED  
NOV 14 2002  
GROUP 3600